

#412  
00001  
5/12/03

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Shih-Ming Wang

Group Art Unit: 2814

Serial No.: 09/974,584

Examiner: Pham, Long

Filed: Oct. 9, 2001

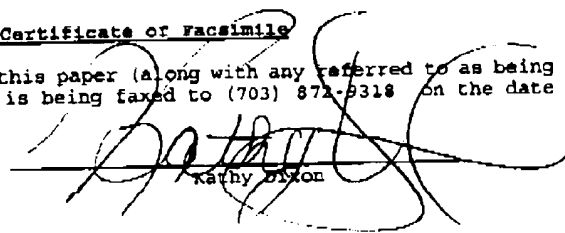
In Response to Office Action  
Dated: Feb. 5, 2003

For: Method for Depositing Silicon Oxide  
Incorporating an Outgassing Step

Attorney Docket No.: 67,200-318

Certificate of Facsimile

I hereby certify that this paper (along with any referred to as being attached or enclosed) is being faxed to (703) 872-9318 on the date shown below

  
Kathy Dixon

Date: May 5, 2003

RESPONSE TO OFFICE ACTION

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

In response to an Office Action mailed Feb. 5, 2003,  
please enter the following amendments and consider the following  
remarks.

**TUNG &  
ASSOCIATES**  
Intellectual Property Law

Date: May 5, 2003

**TO: Examiner Pham, Long (703) 872-9318**  
**Art Unit: 2814**

FAX Operator: Kathy Dixon

FAX Number: (248) 540-4035

Telephone Number: (248) 540-4040

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Subject Matter: 09/ 974,584 Attorney Doc: 67,200-318

Message:

Total number of pages sent: - 14 - (including this cover sheet)